

[NAME OF DOCUMENT] ABSTRACT OF THE DISCLOSURE

[Abstract]

[Subject]

5       An apparatus for assembling substrates comprising a  
pressurizing plate which holds a counter substrate  
directly above a table facing a substrate placed on the  
table, wherein said pressurizing plate comprises vacuum  
holding means which allows individual control of a  
plurality of vacuum-holding areas and electrostatically  
10   holding means which also allows individual control of a  
plurality of electrostatically holding areas; the entire  
surface of said counter substrate is vacuum held under  
atmospheric pressure; and substrate holding mechanisms are  
provided so that the middle portions of a pair of opposite  
15   sides of said counter substrate can be mechanically held  
at a higher location than the peripheral portions when the  
vacuum-holding force in the vacuum chamber decreases.